

Commissioning Status & Beam Parameters for 2020

FACET-II Science Workshop, October 29-November 1, 2019

Jerry Yocky
FACET-II Accelerator
Physics and Beam
Operations
Department Head







FACET-II Start of Commissioning

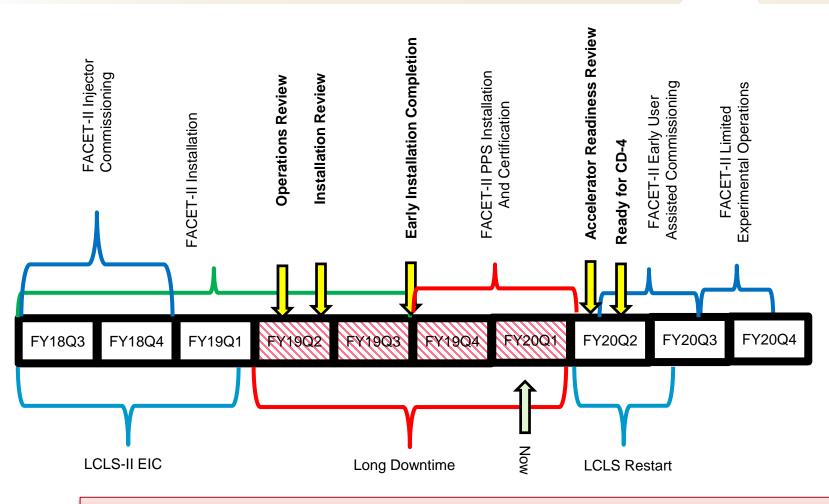


- FACET-II ready for startup Feb/Mar 2020
 - Final PPS complete in December
 - ARR in January
 - LCLS Cu linac restart in February
- Will commence with laser cleaning as early as possible
 - Procedure adopted from established LCLS successes and tweaked by knowledgeable experts in group
 - Investigating feasibility of beginning prior to final beam authorization

FACET-II Commissioning Plans Developed

FACET-II Installation and Commissioning Timeline





A look back at and into the near-future of FACET-II

Checkout Activities

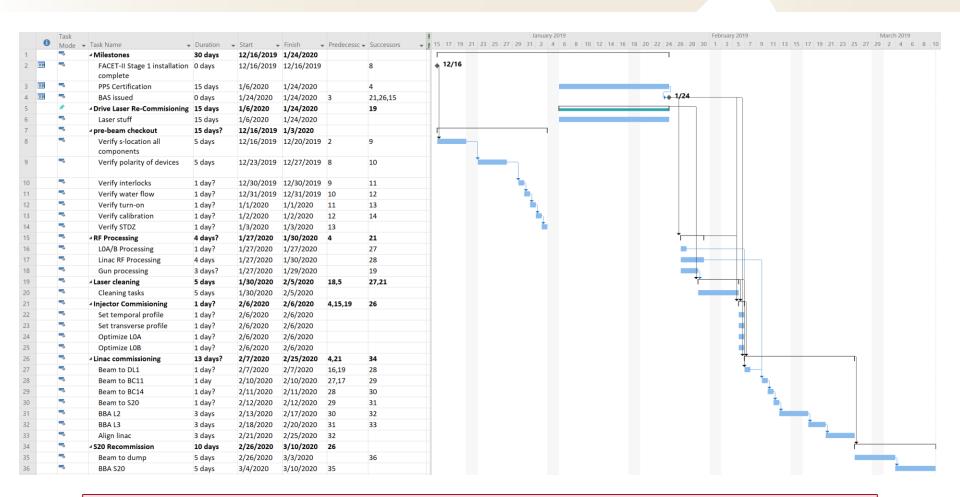


		ı			T							
	Ops	ADSO	RP	PHYS	CTRL	CBL	FAC	PEM	AMRF	MFD	Eng	AM
Cold checkout												
Shielding in place	х	х	Х									х
PPS system certified	х	х	Х		Х							
BCS system certified	х	х	Х		Х							
Water flow							Х				х	
Air flow							Х					
Electrical (EEIP)					Х			Х				
Cable checkout					Х	Х		Х				
Leak check										Х		
Alignment				x-data						Х		
Movement checks				х	Х							
Component software checks					Х							
Control system checks	х				Х							
Magnet polarity				х				Х				
Correct beamline components				Х							Х	
Overall tunnel site check				х							Х	х
Hot checkout												
Magnet checkout	х				Х			Х				
RF checkout	х			х	Х			Х	х			
Timing checkout	х			х	Х				х			

Groups Identified for Cold and Hot Checkout Activities

FACET-II Commissioning Plan





High level commissioning plan developed; Detailed plan in progress and complete before ARR

Commissioning Goals and Schedule



Subsystem goals and daily shift plans developed

Day #	Goal	Goal	Goal	Goal	Goal	•
-n	Laser Cleanin	ng				
0	BAS signed					
1	Process gun	Process L0A	Process L0B		Diagnostics c	heckout
2	Process gun	Process L0A	Process L0B		Diagnostics c	heckout
3	Process gun	Process L0A	Process L0B		Diagnostics c	heckout
4	Process gun	Process L0A	Process L0B	Process linac	RF	Diagnostics checkout
5	Process gun	Process L0A	Process L0B	Process linac	RF	Diagnostics checkout
6	Accelerate to	135MeV	TCAV 0		Process linac	RF
7	Accelerate to	135MeV	TCAV 0		Process linac	RF
8	Accelerate to	335Mev			Process linac	RF
9	Beam through	n BC11			Process linac	RF
10	Beam through	n L2			Process linac	RF
11	Beam through	n BC14				TCAV 3 checkout
12	TCAV 3					
13	TCAV 3					
14	Beam through	n L3				
15	Beam to S20					
16	Beam to S20	•				
17	linac BBA	XTCAV recom	nmission			
18	linac BBA					
19	linac BBA					
20	S20 BBA					
21	S20 BBA					
22	Optimize com	•				
23	Optimize com	•				
24	Optimize com	pression				
	Ontinaina ann					

Daily schedule built with flexibility in mind

Key Performance Parameters



- The threshold KPPs are the minimum parameters against which the project's performance is measured
- The objective KPPs are the desired operating parameters that the project will design to

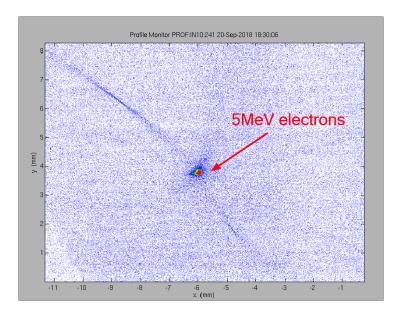
Description of Scope	Units	Threshold KPP	Objective KPP
Beam Energy	[GeV]	9	10
Bunch Charge (e-)	[nC]	0.1	2
Normalized Emittance in S19 (e-)	[µm]	<i>50</i>	20
Bunch Length (e-)	[µm]	100	20

Objective KPP will support the majority of the proposed science program FACET-II flexibility allows other optimizations to meet User needs

FACET-II Subsystem Goals

SLAC

- Laser
 - 50uJ, 2mm laser spot to cathode
 - Delivered 15-Sep-2018
- Gun
 - 5MeV electrons to fixed Faraday cup
 - Delivered 21-Sep-2018
- Injector
 - 100pC 135MeV electrons to DL1
 - Diagnostics checkout (detectable beam)
- BC11
 - 100pC 335MeV electrons to BC 11 screen
 - Diagnostics checkout (detectable beam)
- BC14
 - 100pC 4.5GeV electrons to S15 wires
 - Diagnostics checkout (detectable beam)
 - TCAV calibration
- L3
 - 100pC 8GeV electrons to S18 wire
 - Size measurements
- BC20
 - 100pC 9GeV electrons to experimental area
 - Diagnostics checkout (detectable beam)



5MeV electrons to profile monitor

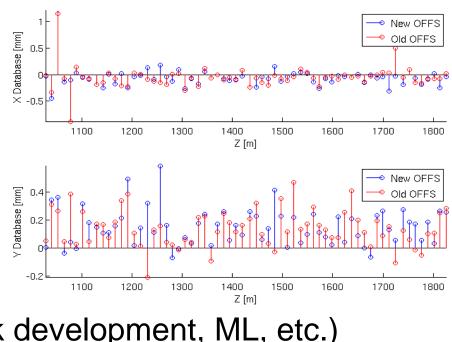
FACET-II Initial Tuning Focus



- Laser Stability
- Linac:
 - Beam Based
 Alignment (BBA)
 - Klystron phase stability
 - Compression

 -0.2 1100 1200 1300 1400 1500 1600

 management (feedback development, ML, etc.)
- S20 configuration development
 - Three main configurations (GW talk)



Laser Cleaning Experience in LCLS



Extensive studies of laser cleaning at LCLS & ASTA

Table 2. Laser cleaning parameters for ASTA compared to previous cle parenthesis were used at the LCLS.

Laser cleaning parameters	ASTA (LCLS)	5 1000 2			
Laser pulse length in ps FWHM	1.6 (~3)	0 1000 2			
Laser size for cleaning in x/y in µm, rms	~40 (~30)				
Laser shots per spot	60 (120)	Fig.6. Laser energy and gun vacuum activit			
Laser wavelength in nm	253 (253)	round of laser cleaning.			
Laser raster step size in x/y in µm	30 (30)				
Base gun vacuum range with RF power off	cuum range with RF power off 4×10^{-10} to 1.2×10^{-9} Torr $(4\times10^{-10}$ to 7×10^{-10} Torr)				
RF power is off during laser cleaning	•				

Multi-round laser cleaning:

- start with 7 μJ (17 μJ)
- laser energy for subsequent rounds is increased in $0.5\text{-}1\mu\mathrm{J}$ (1-2 $\mu\mathrm{J}$)
- take 3-8 rounds (2-3 rounds) until QE up to $3-5\times10^{-5}$

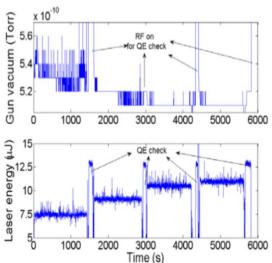


Fig.6. Laser energy and gun vacuum activity during the laser cleanings at ASTA. The QE is checked between each round of laser cleaning.

High Level Application Deployment



- Many Matlab GUIs adapted from LCLS-I
 - Reuse profile monitor, correlation plot, laser cathode alignment, QE imaging, RF sync, and beam synchronous acquisition
 - Some new algorithms required based on beamline instrumentation – phase, amplitude, and Schottky scans
- FACETHome EDM launch panel has started update for FACET-II use
- New link node MPS system
- New summary and status displays for operations, using PyDM

Further application deployment will be interleaved with commissioning activities

Run Hours



- Plan for User Assisted Commissioning (UAC)
 - Commission diagnostics at machine-experiment interfaces
 - 4-5 days/week of delivery or machine development (MD)
 - Other days are either machine access for repairs and experimental setup, software development, or operator training
- Plan for operation of 26 weeks, 5-6 days/week
 - ~3000 total hours
 - ~2250 hours experimental time
 - ~750 hours MD
 - MD initially heavy on commissioning activities
 - Transition into experimental configuration development
 - Development of future extensions to experimental delivery capabilities
 - 80% availability

FACET-II Operation Modes



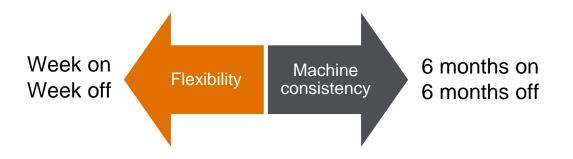
Simplified injector system and LCLS operations experience allows us to consider different patterns for 6 months/year operations:

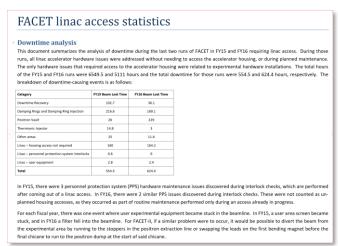
1 week on - 1 week off

2 weeks on - 2 weeks off

. . .

6 months on - 6 months off



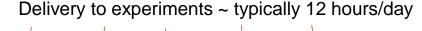


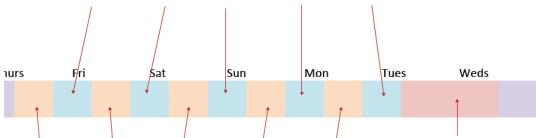
FACET linac access statistics support FACET-II operational mode assumptions

Experience will guide optimal operational mode

Daily Planning: A typical week at FACET







Machine maintenance, development of new beam configurations and set-up for experiments during day shift

Scheduled access to FACET to switch experiments, install upgrades and troubleshoot issues

- Users provided procedures for their beam time + previous shift analysis
 - Advanced Accelerator Research department reviewed to ensure beam time is used effectively
 - Beam needs were relayed by AAR department to Operations department
 - Operations department developed beam configuration and procedures
 - Hardware/support needs were assessed and provided by TF department
- During shift: Regular contact between users and AAR department staff
- After shift: Users post shift report to e-log giving immediate feedback

Feedback between all stakeholders to produce efficient, excellent science

Summary



- Commissioning to begin when PPS certified and within constraints of LCLS Cu linac restart
- Daily commissioning activity plans and goals developed
- Startup schedule flexible to accommodate LCLS recommissioning and other unknowns

FACET-II Accelerator Physics and Beam Operations Department is ready for the start of commissioning